

FORM PTO-1449 INFORMATION DISCLOSURE CITATION			Atty Docket 21994/0040	Serial No. To be assigned			
			Applicant Mikio OKUMURA et al.				
			Filing Date Herewith	Group Art Unit To be assigned			
U.S. PATENT DOCUMENTS							
Examiner Initial		Document Number	Date	Name	Class	Sub-Class	Filing Date
<i>PM</i>	AA	6,198,565	03/2001	Iseki et al.			
	AB						
	AC						
	AD						
	AE						
	AF						
	AG						
	AH						
	AI						
	AJ						
	AK						
FOREIGN PATENT DOCUMENTS							
		Document Number	Date	Country	Class	Sub-Class	Trans-lation
	AL						Yes No
	AM						Yes No
	AN						Yes No
	AO						Yes No
	AP						Yes No
OTHER (Including Author, Title, Date, Pertinent Pages, etc.)							
	AR	Y. Yee et al., "PZT Actuated Micromirror For Nano-Tracking Of Laser Beam For High-Density Optical Data Storage", IEEE MEMS2000, January 2000, pps. 435-440					
	AS						
	AT						
Examiner	<i>Peter Macchiaroli</i>			Date Considered 4-5-04			
EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP § 600. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to Applicant(s).							